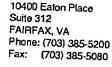
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**KEATING & BENNETT LLP** 

CENTRAL FAX CENTER

FEB 1 0 2004





To:	2800 Customer Service	From: Joseph R. Keating
Fax:	703-872-9306	Date: February 10, 2004
Phone	e: 571-272-2800	Pages: 13
Re:	10/699,460	CC:
፤	70404.10	
·Com	ments:	

Please find attached hereto a Preliminary Amendment to be filed in the above-identified application.

Respectfully submitted,

Joseph R. Keating

(Registration Number: 37,368)

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### CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted to Group Art Unit 2812, 703-873-9306, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: February 10, 2004

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**PATENT** 70404.10

# Sonia V. McVean

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Naoki MAKITA et al.	
Serial No.: 10/699,460	Art Unit: 2812
Filed: November 3, 2003	Examiner: Unknown
Title: SEMICONDUCTOR FILM, METHOD FOR MANUFACTURING SEMICONDUCTOR FILM, SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	÷

### PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

⊠ . □ . begins on p	mendments to the Specification begin on page 2 of this paper.  mendments to the Claims are reflected in the listing of the claims which  age of this paper.				
an attached	Amendments to the Drawings begin on page of replacement sheet. An Appendix including the a following page of this paper.  Remarks/Arguments begin on page 11 of this paper.	•			

Please note, if a box is not checked, then no corresponding amendment is being made.